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APPLICATION NUMBER	FILING OR 371(c) DATE	FIRST NAMED APPLICANT	ATTY. DOCKET NO./TITLE
10/595,203	03/23/2006	Sung Soo Si	2017-72

**CONFIRMATION NO. 4577**

52706  
IPLA P.A.  
3580 WILSHIRE BLVD.  
17TH FLOOR  
LOS ANGELES, CA90010

**Title:** Plasma rapid thermal process apparatus in which supply part of radical source is improved

**Publication No.** US-2007-0032090-A1

**Publication Date:** 02/08/2007

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